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PTO/SB/21 (12-97)

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# TRANSMITTAL FORM

(to be used for all correspondence after initial filing)

<b>Application Number</b>	09/625,336
<b>Filing Date</b>	7/25/2000
<b>First Named Inventor</b>	Kori, Moris
<b>Group Art Unit</b>	Unassigned
<b>Examiner Name</b>	Unassigned
<b>Total Number of Pages in This Submission</b>	5
<b>Attorney Docket Number</b>	4742/AMI-00-07

## ENCLOSURES (check all that apply)

<input type="checkbox"/> Fee Transmittal Form <input type="checkbox"/> Fee Attached <input type="checkbox"/> Amendment / Response <input type="checkbox"/> After Final <input type="checkbox"/> Affidavits/declaration(s) <input type="checkbox"/> Extension of Time Request <input type="checkbox"/> Express Abandonment Request <input checked="" type="checkbox"/> Supplemental Information Disclosure Statement <input type="checkbox"/> Certified Copy of Priority Document(s) <input type="checkbox"/> Response to Missing Parts/ Incomplete Application <input type="checkbox"/> Response to Missing Parts under 37 CFR 1.52 or 1.53	<input type="checkbox"/> Assignment Papers (for an Application) <input type="checkbox"/> Drawing(s) <input type="checkbox"/> Licensing-related Papers <input type="checkbox"/> Petition Routing Slip (PTO/SB/69) and Accompanying Petition <input type="checkbox"/> To Convert a Provisional Application <input type="checkbox"/> Power of Attorney, Revocation Change of Correspondence Address <input type="checkbox"/> Terminal Disclaimer <input type="checkbox"/> Small Entity Statement <input type="checkbox"/> Request of Refund	<input type="checkbox"/> After Allowance Communication to Group <input type="checkbox"/> Appeal Communication to Board of Appeals and Interferences <input type="checkbox"/> Appeal Communication to Group (Appeal Notice, Brief, Reply Brief) <input type="checkbox"/> Proprietary Information <input type="checkbox"/> Status Letter <input checked="" type="checkbox"/> Additional Enclosure(s) (please identify below): Return Receipt Postcard to Kenneth C. Brooks 1449 with 4 references
<b>Remarks</b>		

## SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT

<b>Firm or Individual name</b>	Kenneth C. Brooks
<b>Signature</b>	
<b>Date</b>	October 17, 2000

## CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231 on this date:			
<b>Type or printed name</b>	Kenneth C. Brooks		
<b>Signature</b>		<b>Date</b>	October 17, 2000

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Kori et al.

PATENT APPLICATION

Serial No: 09/625,336

Group Art Unit: unassigned

Filed: July 25, 2000

Examiner: unassigned

For: METHOD AND SYSTEM FOR CONTROLLING THE PRESENCE OF  
FLUORINE IN REFRACTORY METAL LAYERS

Supplemental Information Disclosure Statement

Hon. Assistant Commissioner

for Patents

Washington, D.C. 20231

Sir:

The following information is submitted in compliance with Applicants' duty of disclosure under 37 C.F.R. § 1.56. A copy of each reference recited below accompanies this document.

PATENT DOCUMENTS

<u>Patent Number</u>	<u>Inventors</u>	<u>Grant Date</u>
5,972,430	DiMeo, Jr. et al.	Oct. 26, 1999
5,916,365	Sherman	Jun. 29, 1999
<u>Application Number</u>	<u>Inventors</u>	<u>Filing Date</u>
09/678,266	Xi et al.	Oct. 3, 2000



NON-PATENT DOCUMENTS

Choi, et al., The Effect of Annealing on Resistivity of Low Pressure Chemical Vapor Deposited Titanium Diboride. J. Appl. Phys. 69 (11), 1 June 1991. Pages 7853-7861.

Choi et al. Stability of  $\text{TiB}_2$  as a Diffusion Barrier on Silicon. J. Electrochem. Soc. Vol. 138, No. 10, October 1991. Pages 3062-3067.

Respectfully submitted,

Kenneth C. Brooks

Reg. No. 38,393